



DOCKET NO: 2312-0866-2PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :
KIMIHIRO MATSUSE ET AL. : GROUP: 2814
SERIAL NO: 09/530,588 : EXAMINER: QUACH, TUAN N.
RCE FILED: HEREWITH :
FOR: METHOD OF FORMING SEMICONDUCTOR WIRING STRUCTURES

SUPPLEMENTAL AMENDMENT

COMMISSIONER FOR PATENTS
Alexandria, VA 22313-1450

SIR:

In response to the Office Action mailed July 18, 2003, and supplemental to the Amendment filed October 20, 2003, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.